

**S/N 10/681,481**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Paul A. Farrar	Examiner:	Joy L. Watson
Serial No.:	10/681,481	Group Art Unit:	1792
Filed:	October 8, 2003	Docket No.:	1303.112US1
Title:	METHOD OF CLEANING SEMICONDUCTOR SURFACES		

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**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This responds to the Office Action mailed on February 12, 2008. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from May 12, 2008 to June 12, 2008.